



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takayoshi Sawayama

Group Art Unit: 1763

Serial No.: 09/754,277

Examiner: Alejandro Mulero, Luz L

Filed: January 5, 2001

For: PLASMA ETCHING APPARATUS

#3
1/17/02
Mh

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Honorable Commissioner of
Patents and Trademarks,
Washington, D.C. 20231

Sir:

In response to the Office Action of December 18, 2001, Applicant elects the invention of specie B, which corresponds to claims 3-7, directed to an apparatus comprising a pressure detecting means. The election is without traverse.

Respectfully submitted,

VOLENTINE FRANCOS, PLLC

Adam C. Volentine
Registration No. 33,289

12200 Sunrise Valley Drive, Suite 150
Reston, Virginia 20191
Telephone No.: (703) 715-0870
Facsimile No.: (703) 715-0877

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